

Notice of References Cited	Application/Control No. 10/656,223	Applicant(s)/Patent Under Reexamination CHOU ET AL.	
	Examiner Tamai IE Karl	Art Unit 2834	Page 1 of 1

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	C	US-6,628,041	09-2003	Lee et al.	310/309
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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